

L Number	Hits	Search Text	DB	Time stamp
1	60616	template	USPAT; EPO; JPO; DERWENT	2002/06/21 09:25
2	697	nanoparticle nanomer	USPAT; EPO; JPO; DERWENT	2002/06/21 09:25
3	316161	deposition	USPAT; EPO; JPO; DERWENT	2002/06/21 09:25
4	119822	427/\$.ccls.	USPAT; EPO; JPO; DERWENT	2002/06/21 09:26
5	32734	205/\$.ccls.	USPAT; EPO; JPO; DERWENT	2002/06/21 09:26
6	1106449	semiconductor	USPAT; EPO; JPO; DERWENT	2002/06/21 09:26
7	132636	metal adj (oxide chalcogenide oxide sulfide)	USPAT; EPO; JPO; DERWENT	2002/06/21 09:27
8	51009	metal adj (selenide telluride alloy nitride)	USPAT; EPO; JPO; DERWENT	2002/06/21 09:27
9	322	metal adj (phosphide antimonide)	USPAT; EPO; JPO; DERWENT	2002/06/21 09:27
10	178597	((metal adj (oxide chalcogenide oxide sulfide)) (metal adj (selenide telluride alloy nitride)) (metal adj (phosphide antimonide)))	USPAT; EPO; JPO; DERWENT	2002/06/21 09:27
11	1238387	((metal adj (oxide chalcogenide oxide sulfide)) (metal adj (selenide telluride alloy nitride)) (metal adj (phosphide antimonide))) semiconductor	USPAT; EPO; JPO; DERWENT	2002/06/21 09:28
12	7	((metal adj (oxide chalcogenide oxide sulfide)) (metal adj (selenide telluride alloy nitride)) (metal adj (phosphide antimonide))) semiconductor) and deposition and (nanoparticle nanomer) and template	USPAT; EPO; JPO; DERWENT	2002/06/21 09:30
14	2	((metal adj (oxide chalcogenide oxide sulfide)) (metal adj (selenide telluride alloy nitride)) (metal adj (phosphide antimonide))) semiconductor) and deposition and (nanoparticle nanomer) and 205/\$.ccls.	USPAT; EPO; JPO; DERWENT	2002/06/21 09:31
13	22	((metal adj (oxide chalcogenide oxide sulfide)) (metal adj (selenide telluride alloy nitride)) (metal adj (phosphide antimonide))) semiconductor) and deposition and (nanoparticle nanomer) and 427/\$.ccls.	USPAT; EPO; JPO; DERWENT	2002/06/21 09:31